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Temperature and Doping Dependencies of Electron Mobility in InAs, AlAs and AlGaAs at High Electric Field Application

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Temperature and doping dependencies of electron mobility in InAs, AlAs and AlGaAs structures have been calculated using an ensemble Monte Carlo simulation. Electronic states within the conduction band valleys at the Γ , L and X are represented by non-parabolic ellipsoidal valleys centred on important symmetry points of the Brillouin zone. The simulation shows that intervalley electron transfer plays a dominant role in high electric fields leading to a strongly inverted electron distribution and to a large negative differential conductance. Our simulation results have also shown that the electron velocity in InAs and AlAs is less sensitive to temperature than in other III-V semiconductors like GaAs and AlGaAs. So InAs and AlAs devices are expected to be more tolerant to self-heating and high ambient temperature device modeling. Our steady-state velocity-field characteristics are in fair agreement with other recent calculations.

Keywords: Electron Mobility; Steady-state; Ellipsoidal valleys; Self-heating

1. INTRODUCTION

GaAs and related compounds with aluminium and indium currently have great potential for applications in optoelectronic devices, high frequency applications and quantum dots (QD's) infrared photodetectors [1-4]. Different GaAs/AlAs electronic and optoelectronic devices with quantum effects are currently commercially available. An increasing tendency in such devices is the implementation of complicated multi-layered nano-systems, containing two or more components interacting with each other. The Monte Carlo technique has proved valuable for studying non-equilibrium carrier transport in a range of semiconductor materials and devices [5-8], and electron transport in bulk semiconductor was modelled as long ago as 1966 [9]. However, carrier transport modelling has only recently begun to receive sustained attention [10-11], now that the growth of compounds and alloys is able to produce viable material for the electronics industry. As the start of a programme of work modelling high field transport and breakdown in InAs, AlAs and AlGaAs, this paper presents the results of Monte Carlo simulations of electron transport in bulk InAs, AlAs and AlGaAs at different temperature and electron concentrations. The simulations have been carried out using a non-parabolic ellipsoidal valley model to describe transport in the conduction band. This article is organised as follows.

Details of the conduction band parameters and the Monte Carlo simulation are presented in section 2, and the results of steady state and transient transport simulations are discussed in section 3.

2. SIMULATION MODEL

In order to calculate the electron drift velocity for large electric fields, consideration of conduction band satellite val-

leys is necessary. The first-principles band structure of zincblende InAs, AlAs and AlGaAs predicts a direct band gap located at the Γ point and lowest energy conduction band satellite valleys at the X point and at the L point. In our Monte Carlo simulation, the Γ valley, the three equivalent X valleys, the four equivalent L valleys, are represented by ellipsoidal, nonparabolic dispersion relationships of the following form [12-13]

$$E(\mathbf{k})[1 + \alpha_i E(\mathbf{k})] = \frac{\hbar^2 k^2}{2m^*} \quad (1)$$

where m^* is effective mass at the band edge and α_i is the non-parabolicity coefficient of the i -th valley. The band structure and material parameters necessary for calculating the scattering probabilities used in the present Monte Carlo simulation are given in table 1 and 2. Scattering mechanisms included in the simulation are acoustic deformation potential scattering (treated either as an elastic process or as an inelastic process) and piezoelectric scattering (which is found to be negligible in the temperature range discussed here). Furthermore, longitudinal optical phonon scattering, nonequivalent and, where applicable, equivalent intervalley scattering events are taken into account among all valley types with the transfers assumed to be governed by the same deformation potential fields and the same phonon frequencies. Degeneracy effects are expected to be negligible over almost all of the temperature and electron concentration ranges of interest here and, hence, are not considered in the calculation.

In our model at the start of each simulation, ten thousand electron particles are distributed in momentum space according to a Maxwell-Boltzmann distribution function. These particles are propagated classically between collisions according to their velocity, effective mass and the prevailing field. The selection of the propagation time, scattering mechanism and other related quantities is achieved by generating random numbers and using these numbers to select, for example, a scattering mechanism. In the case of the ellipsoidal, non-parabolic

conduction valley model, the usual Herring-Vogt transformation matrices are used to map carrier momenta into spherical valleys when particles are drifted or scattered. Steady-state results of high field transport studies have been obtained for lattice temperatures up to 400 K, in order to gain some insight into the hot carrier transport and the energy distribution function that would be generated in the gate-drain region of a power field effect transistor.

TABLE I: Important band parameters used in the Monte Carlo simulation for zincblende AlAs, AlGaAs and InAs.

	Valley	$E_{gap}(\text{eV})$	m^*	Nonparabolicity (eV^{-1})
AlAs	Γ	2.95	0.146	0.25
	L	3.05	0.19	0.029
	X	3.2	0.6	0.08
AlGaAs	Γ	1.82	0.086	0.55
	L	1.93	0.233	0.62
	X	1.97	0.411	0.325
InAs	Γ	0.356	0.027	2.66
	L	0.73	0.64	0.7
	X	1.02	0.286	1.5

TABLE II: Material parameter selections for AlAs, AlGaAs, and InAs.

	AlAs	AlGaAs	InAs
Density $\rho(\text{kgm}^{-3})$	5667	4200	5370
Longitudinal sound velocity $v_s(\text{ms}^{-1})$	4280	5130	5500
Low-frequency dielectric constant ϵ_s	14.6	11.4	12.5
High-frequency dielectric constant ϵ_∞	12.25	10.5	8.7
Acoustic deformation potential $D(\text{eV})$	4.9	8.3	8.8
Polar optical phonon energy $\hbar\omega_{po}(\text{eV})$	0.015	0.09	0.02
Energy gap (eV)	0.356	1.82	1.43
Lattice constant $a_0(\text{\AA})$	3.39	2	6.2
Intervalley deformation potentials (10^7eVm^{-1})	1	1	1
Intervalley phonon energies (meV)	11.2	26	32.2

3. RESULTS

Electron drift velocity as a function of electric field is important in determining the performance of high-speed and microwave semiconductor devices. Here we show the results of temperature dependence of the steady-state velocity-field characteristics and valley occupancy in bulk InAs, AlAs and AlGaAs materials. Fig. 1 shows the simulated velocity-field characteristics at 300 K, with a background doping concentration of 10^{17}cm^{-3} , and with the electric field applied along one

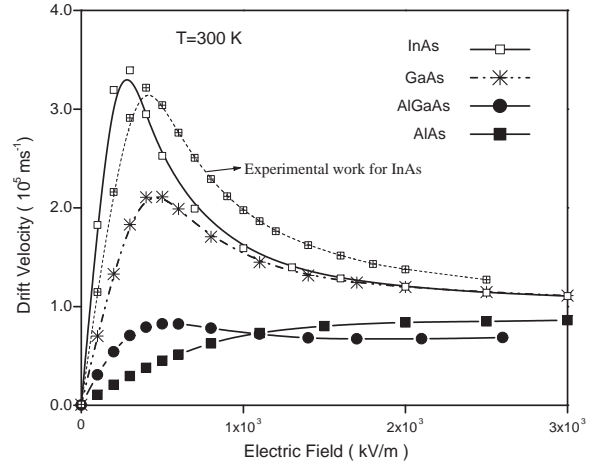


FIG. 1: Calculated steady-state electron drift velocity in bulk zincblende InAs, AlAs and AlGaAs using non-parabolic band models in comparison with GaAs material and experimental measurements of Brennan *et al.* [14].

of the cubic axes.

Similar to the experimental results the simulations suggest that the peak drift velocity for zincblende InAs is $\sim 3.4 \times 10^5 \text{ms}^{-1}$ while those for AlAs and AlGaAs are about $0.8 \times 10^5 \text{ms}^{-1}$ and 10^5ms^{-1} , respectively. At higher electric fields, intervalley optical phonon emission dominates, causing the drift velocity to saturate at around $1.2 \times 10^5 \text{ms}^{-1}$. The calculated high field electron drift velocity apparent from Fig. 1 is fractionally lower than those that have been simulated by Adachi *et al.* [4-5] who assumed an effective mass in the upper valleys equal to the free electron mass. The threshold field for the onset of significant scattering into satellite conduction band valleys is a function of the intervalley separation and the density of electronic states in the satellite valleys.

The importance of electron intervalley transfer at high electric fields can be clearly seen in Fig. 2. In this figure the fractional valley occupancies for different materials is plotted. It is obvious that the inclusion of satellite valleys in the simulations is important. Significant electron transfer to the upper valleys only begins to occur when the field strength is very close to the threshold value. At the threshold field the electron valley occupancies at room temperature for Γ , L and X are about 85%, 13% and 2%, respectively.

Figure 3 shows the calculated electron drift velocity as a function of electric field strength for temperatures of 300, 350 and 400 K. The decrease in drift mobility with temperature at low fields is due to increased intravalley polar optical phonon scattering whereas the decrease in velocity at higher fields is due to increased intra and intervalley scattering. It can be seen from the figure that the peak velocity also decreases and moves to higher electric field as the temperature is increased. This is due to the general increase of total scattering rate with temperature, which suppresses the electron energy and reduces the population of the satellite valleys. This latter effect is apparent from the fact that the electron population in the central Γ -valley increases with temperature as shown in

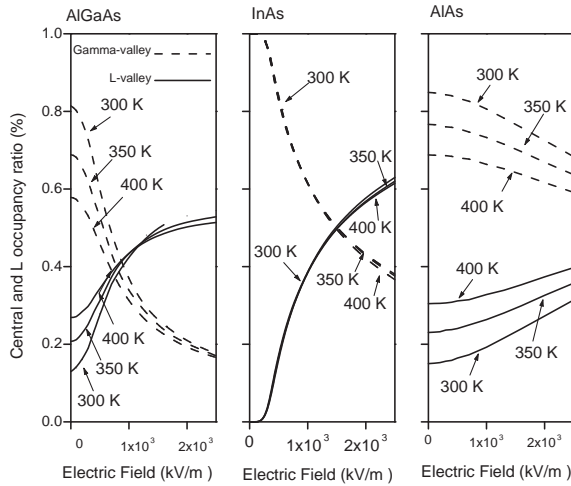


FIG. 2: Fractional occupation of the central and satellite valleys in InAs, AlAs and AlGaAs as a function of applied electric field using the non-parabolic band model at different temperatures up to 400 K.

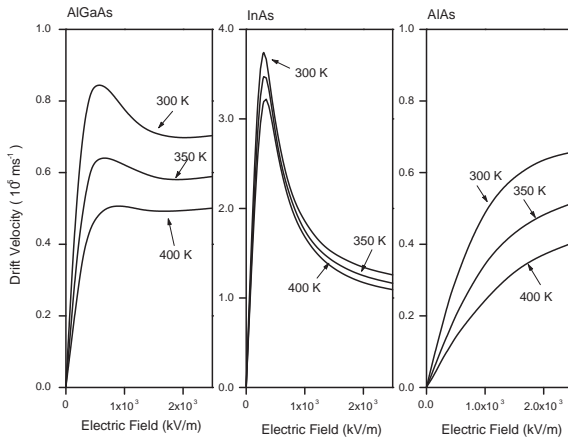


FIG. 3: Calculated electron steady-state drift velocity in bulk InAs, AlAs and AlGaAs as a function of applied electric field at various lattice temperatures and assuming a donor concentration of 10^{17} cm^{-3} . The peak drift velocity decreases while the threshold field increases by same percent as the lattice temperature increases from 300 to 400 K.

Fig. 2.

Figure 4 shows how the velocity-field relation changes with temperature for electrons in the most populated Γ and L valleys. There are significant statistical fluctuations in the results for the drift velocity of electrons in the L valleys for fields around 500 kV m^{-1} , which are caused by the relatively small number of electron particles occupying the valleys just above the threshold for intervalley transfer. Nevertheless it can be

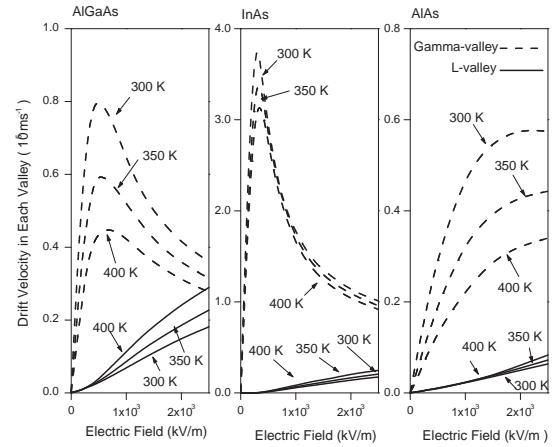


FIG. 4: Temperature dependence of the drift velocity in the Γ and L valleys of InAs, AlAs and AlGaAs materials as a function of applied electric field.

seen that the average drift velocity decreases as the temperature increases for both valleys. Comparison of the temperature dependence of the transport properties in InAs, AlAs and AlGaAs materials show that the change in peak velocity of AlGaAs from 300 K to 400 K is a reduction of about 45% whereas for InAs and AlAs, it is about 25% and 20%, respectively. The reason can be explained in terms of the energy band structure. In particular, the different electron effective mass within the central valley ($0.027 m_0$ in InAs versus $0.086 m_0$ and $0.146 m_0$ in AlGaAs and AlAs, respectively). This is important because electrons which are near a valley minimum have small kinetic energies and are therefore strongly scattered. It is apparent that intervalley transfer is substantially larger in InAs over the range of applied electric fields shown, due to the combined effect of a lower Γ effective mass, lower satellite valley separation energy, and slightly lower phonon scattering rate within the Γ valley.

Therefore, the electron velocity in InAs and AlAs is less sensitive to temperature than in AlGaAs, so InAs devices are expected to be more tolerant to self-heating and high ambient temperature.

Figure 5 shows how the velocity-field characteristic of InAs, AlAs and AlGaAs materials change with impurity concentration at 300 K. It is clear that with increasing donor concentration, there is a reduction in the average peak drift velocity and the threshold field because of increasing scattering rate events. The results show the trend expected from increased ionized impurity scattering in good general agreement with recent calculations by other workers [14–16].

4. CONCLUSIONS

Electron transport at different temperatures in bulk zincblende InAs, AlAs and AlGaAs have been simulated

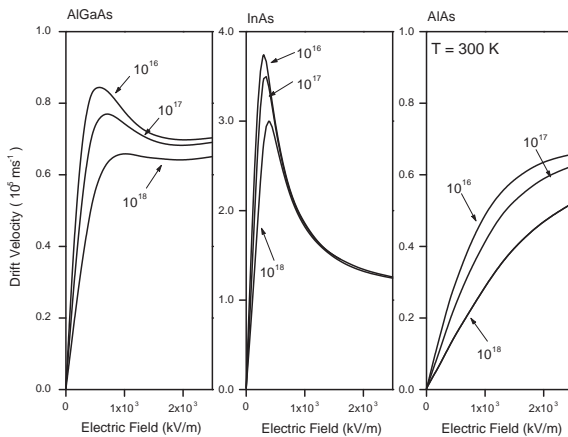


FIG. 5: Calculated electron steady-state drift velocity in bulk InAs, AlAs and AlGaAs as a function of applied electric field at various donor concentration up to 10^{18} cm^{-3} at room temperature. The peak drift velocity decreases due to increasing scattering rate.

5. ACKNOWLEDGMENTS

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